

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Uwe SCHWARZ

Serial No: 10/537,211

Examiner: Reema Patel

Filed: March 20, 2006

Group Art Unit: 2812

Conf.: 1865

For: PRODUCTION OF MICROELECTROMECHANICAL SYSTEMS (MEMS) USING  
THE HIGH TEMPERATURE SILICON FUSION BONDING OF WAFERS

AMENDMENT, 37 C.F.R. §1.111

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby responds to the official action mailed May 15, 2007. Submitted  
are:

- a set of amended claims to replace the claims of record,
- applicant's remarks, and
- a petition for retroactive extension (2 months).

No new matter is presented. The official fees required for the requested  
extension is being submitted by EFS charge to a Deposit Account. Please charge any  
underpayment or credit any overpayment to Deposit Account 04-1679.

Reconsideration and allowance are requested.

Date: October 12, 2007

Attorney Docket: D4695-00135  
[11415us/Mij]

Respectfully submitted,

/Stephan Gribok/  
Stephan P. Gribok, Reg. No. 29,643  
DUANE MORRIS LLP  
30 South 17<sup>th</sup> Street  
Philadelphia, PA 19103-4196  
Telephone: 215-979-1283  
Facsimile: 215-979-1020  
spgribok@duanemorris.com